



PATENT  
Attorney Docket No. 01-099

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8/1/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Rongxiang Hu, Philippe Schoenborn,  
and Masaichi Eda  
Serial No. 09/928,570  
Filed: August 13, 2001  
For: HIGH SELECTIVELY SiC ETCH  
IN INTEGRATED CIRCUIT  
FABRICATION

Group Art Unit: 1765  
Confirmation No. 7873  
Examiner: L. Umez-Eronini

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GROUP 1700

Response to Notice of Non-Compliant Amendment

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Non-Compliant Amendment dated July 17, 2003, submitted herewith is a revised Amendment and Response to First Office Action revising Claim 7 to include the status identifier. It is believed that the Amendment and Response as revised complies with the voluntary practice guidelines and/or 37 CFR 1.121.

It is respectfully requested that the attached revised Amendment and Response to First Office Action be substituted for the previously submitted non-compliant Amendment and Response to First Office Action.

Date: 7/22/03

By:   
John R. Ley, Registration No. 27,453  
ATTORNEY FOR APPLICANT

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